

PTO-1449		Application No.		Applicant(s)			
		10/774,222		Jean Woloszko et al.			
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<b>Information Disclosure Citation in an Application</b>		CB-16		3739		February 5, 2004	
		<b>U.S. PATENT DOCUMENTS</b>					
		<b>DOCUMENT NO.</b>	<b>DATE</b>	<b>NAME</b>	<b>CLASS</b>	<b>SUBCLASS</b>	<b>FILING DATE</b>
/MP/	A.	4,418,692	12/6/83	Guay	606	42	11/17/78
	B.	4,474,179	10/02/84	Koch	606	40	05/13/82
	C.	4,907,589	03/13/90	Cosman	606	34	04/29/88
	D.	6,261,311	07/17/01	Sharkey et al.	607	96	7/30/99
	E.	6,749,604	06/15/04	Eggers et al.	606	41	03/30/00
	F.	6,770,071	8/3/2004	Woloszko et al.	606	41	2/9/2001
	G.	6,837,887	1/4/2005	Woloszko et al.	606	41	1/25/2002
	H.	6,837,888	1/4/2005	Ciarrocca et al.	606	41	2/25/2002
	I.	6,984,231	01/10/06	Goble et al.	606	37	08/27/02
	J.	7,169,143	01/30/07	Eggers et al.	606	32	10/20/05
	K.	7,179,255	02/20/07	Lettice et al.	606	32	12/20/00
	L.	7,186,234	03/06/07	Dahla et al.	604	22	02/05/02
	M.	7,192,428	03/20/07	Eggers et al.	606	41	03/20/03
	N.	7,201,750	04/10/07	Eggers et al.	606	41	05/18/99
	O.	7,217,268	05/15/07	Eggers et al.	606	32	06/24/03
	P.	RE33,925	05/12/92	Bales et al.	606	48	12/08/88
	Q.	2002/0029036	03/07/02	Goble et al.	606	38	08/09/01
	R.	2002/0095151	07/18/02	Dahla et al.	606	41	02/05/02
	S.	2003/0028189	02/06/03	Woloszko et al.	604	045	06/27/02
	T.	2003/0088245	05/08/03	Woloszko et al.	606	041	11/04/02
	U.	2003/0158545	08/21/03	Hovda et al.	606	032	02/25/03
	V.	2003/0171743	09/11/03	Tasto et al.	606	032	02/21/03
	W.	2003/0208194	11/06/03	Hovda et al.	606	041	09/26/01
	X.	2003/0208196	11/06/03	Stone	606	041	05/03/02
	Y.	2003/0212395	11/13/03	Woloszko et al.	606	032	03/05/03
	Z.	2003/0212396	11/13/03	Eggers et al.	606	041	03/14/03
	AA.	2004/0024399	02/05/04	Sharps et al.	606	032	07/08/03
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/MP/	CC.	2004/0054366	03/18/04	Davison et al.	606	045	09/12/03
EXAMINER /Michael Peffley/					DATE CONSIDERED 08/11/2007		
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MP/	A.	2004/0127893	07/01/04	Hovda	606	041	12/11/03
	B.	2004/0153057	08/05/04	Davison	600	410	11/13/03
	C.	2004/0116922	06/17/04	Hovda et al.	606	041	09/05/03
	D.	2004/0230190	11/18/04	Dahla et al.	604	041	03/12/04
	E.	2005/0004634	01/06/05	Hovda et al.	606	041	07/29/04
	F.	2005/0010205	01/13/05	Hovda et al.	606	032	03/12/04
	G.	2005/0119650	06/02/05	Sanders et al.	424	426	10/20/04
	H.	2005/0131402	06/16/05	Ciarrocca et al.	600	450	01/03/05
	I.	2005/0187543	08/28/05	Underwood et al.	606	041	04/25/02
	J.	2005/0234439	10/20/05	Underwood et al.	606	032	03/25/05
	K.	2005/0251134	11/10/05	Woloszko et al.	606	032	05/09/05
	L.	2005/0261754	11/24/05	Woloszko et al.	606	032	04/12/05
	M.	2005/0288665	12/29/05	Woloszko et al.	606	041	06/24/05
	N.	2006/0036237	02/16/06	Davison et al.	606	041	06/03/05
	O.	2006/0095026	05/04/06	Hovda et al.	606	032	09/19/05
	P.	2006/0095031	05/04/06	Ormsby, T.	606	034	09/22/05
	Q.	2006/0129145	06/15/06	Ormsby et al.	606	041	10/11/05
	R.	2006/0178670	08/10/06	Woloszko et al.	606	048	01/17/06
	S.	2006/0189971	08/24/06	Eggers et al.	606	032	11/23/05
	T.	2006/0253117	11/09/06	Hovda et al.	128	898	03/09/06
	U.	2006/0259025	11/16/06	Dahla	607	108	05/16/05
	V.	2007/001088	01/11/07	Dahla	606	041	07/06/05
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	Y.	6,878,149	4/12/05	Gatto	606	46	4/2/2002
	Z.	6,892,086	5/10/05	Russell	600	372	10/17/2001
	AA.	6,979,601	12/27/05	Marr et al.	438	132	4/21/2003
	BB.	6,986,700	1/17/06	Hood	451	6	7/21/2003
MP/	CC.	2007/0161981	7/12/2007	Sanders et al.	606	41	1/6/2006
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<b>FOREIGN PATENT DOCUMENTS</b>									
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							YES	NO	
/MP/	A.	05/000434	12/20/06	NL	---	---	X		
/MP/	B.	05/125287	12/29/05	WO	A61B	18/00	X		
/MP/	C.	07/056729	5/18/2007	WO	A61B	18/14	X		
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/MP/	D.	Stoffels, E. et al., "Investigation on the Interaction Plasma-Bone Tissue", E-MRS Spring Meeting, 1 pg						06/18-21/2002	
	E.	Stoffels, E. et al., "Biomedical Applications of Plasmas", Tutorial presented prior to the 55 <sup>th</sup> Gaseous Electronics Conference in Minneapolis, MN, 41 pgs						10/14/02	
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	H.	Stoffels, E. et al., "Plasma Needle", Eindhoven University of Technology, 1 pg						11/28/03	
	I.	Stoffels, E. et al., "Plasma Physicists Move into Medicine", Physicsweb, 1 pg						11/2003	
	J.	Stoffels, E. et al., "Plasma Treated Tissue Engineered Skin to Study Skin Damage", Biomechanics and Tissue Engineering, Materials Technology, 1 pg						2003	
	K.	Stoffels, E. et al., "Plasma Treatment of Dental Cavities: A Feasibility Study", IEEE Transaction on Plasma Science, Vol. 32, No. 4, pp. 1540-1542						08/2004	
	L.	Stoffels, E. et al., "The Effects of UV Irradiation and Gas Plasma Treatment on Living Mammalian Cells and Bacteria: A Comparative Approach", IEEE Transaction on Plasma Science, Vol. 32, No. 4, pp. 1544-1550						08/2004	
	M.	Stoffels, E. et al., "Electrical and Optical Characterization of the Plasma Needle", New Journal of Physics 6, pp. 1-14						10/28/04	
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	Q.	Stoffels, E. et al., "Deactivation of Escherichia Coli by the Plasma Needle", J. Phys. D: Appl. Phys. 38, pp. 1716-1721						05/20/05	
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/MP/	A.	Stoffels, E. et al., "Killing of S. Mutans Bacteria Using a Plasma Needle at Atmospheric Pressure, IEEE Transaction on Plasma Science, Vol. 34, No. 4, pp. 1317-1324			08/2006
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/MP/	F.	PCT Notification of International Search Report and Written Opinion for PCT/US06/26321 (Atty docket no. CB-17PC), 8pgs			Mailed 4/25/07
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